

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Zahorik et al.

Serial No.: 10/647,634

Filed: August 25, 2003

For: METHODS FOR SELECTIVE REMOVAL OF MATERIAL FROM WAFER ALIGNMENT MARKS

Confirmation No.: 3991

Examiner: Unknown

Group Art Unit: 1765

Attorney Docket No.: 2269-3131.6US

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1456.

January 16, 2004

Deidra J. Pfeil Name (Type/Print)

PRELIMINARY AMENDMENT

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Prior to examination of the above-referenced patent application on the merits, entry of the amendments as set forth herein is respectfully solicited.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing which begins on page 6 of this paper.

Remarks begin on page 10 of this paper.